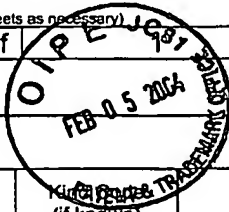


Substitute for form 1449A/PTO & 1449B/PTO			Complete if Known	
FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/670,556
			Filing Date	September 26, 2003
			First Named Inventor	Michael STEIGERWALD
			Examiner Name	Unassigned
			Attorney Dock Number	007413-067
Sheet	1	of		



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NON-PATENT LITERATURE DOCUMENTS	
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101	L. Reimer, "Scanning Electron Microscopy: Physics of Image Formation and Microanalysis," Springer Series in Optical Sciences, pp. 13-19, (1998).

Examiner Signature	<i>James J. Long</i>	Date Considered	7/11/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.